



AMENDMENT TRANSMITTAL LETTER				Docket No. 61179-00007USPX	
Application No. 10/784509-Conf. #1501		Filing Date February 23, 2004		Examiner J. M. Pelham	
Art Unit 3742					
Applicant(s): Flavio Villa et al.					
Invention: PROCESS FOR MANUFACTURING INTEGRATED CHEMICAL MICROREACTORS OF SEMICONDUCTOR MATERIAL					
TO THE COMMISSIONER FOR PATENTS					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	15	- 20 =		x	0.00
Independent Claims	3	- 3 =		x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Non-statutory terminal disclaimer					110.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					110.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> A check in the amount of \$ <u>110.00</u> to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>10-0447</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Tamsen Valoir, Ph.D. Attorney Reg. No.: 41,417				Dated: <u>10-27-2004</u>	
JENKENS & GILCHRIST, A PROFESSIONAL CORPORATION 5 Houston Center 1401 McKinney, Suite 2600 Houston, Texas 77010 (214) 855-4795					